WEST Search History

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DATE: Thursday, January 11, 2007

Hide?	Set Name	Query	Hit Count
		DB=PGPB,USPT; PLUR=YES; OP=ADJ	
☐	L17	L16 and l15	9
☐	L16	134/1.3,2,6,8,17,34,37,42;438/906.ccls.	8454
☐	L15	(semiconductor or wafer or substrate) same supercritical same bubbl$3	39
		DB=EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ	
☐	L14	(semiconductor or wafer or substrate) same supercritical same bubbl$3	6
		DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ	
☐	L13	(semiconductor or wafer or substrate) same supercritical same bubbl$3	45
☐	L12	L3 and ((semiconductor or wafer or substrate) same supercritical same bubbl$3)	4
		DB=PGPB; PLUR=YES; OP=ADJ	
☐	L11	L3and ((semiconductor or wafer or substrate) same supercritical same bubbl$3)	0
		DB=USPT; PLUR=YES; OP=ADJ	
☐	L10	L3and ((semiconductor or wafer or substrate) same supercritical same bubbl$3)	0
☐	L9	L6 and ((semiconductor or wafer or substrate) same supercritical same bubbl$3)	0
☐	L8	L6 and ((semiconductor or wafer or substrate) same supercritical same bubble)	0
☐	L7	L6 and ((semiconductor or wafer or substrate) same supercritical same thermodynamic$4)	0
☐	L6	US-4817652-$.DID. OR US-4944837-$.DID. OR US-4962776-$.DID. OR US-5185296-$.DID. OR US-5304515-$.DID. OR US-5900354-$.DID. OR US-6071439-$.DID. OR US-6149828-$.DID. OR US-6242165-$.DID. OR US-6306754-$.DID. OR US-6666986-$.DID.	11
		DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ	
☐	L5	US-4817652-$.DID. OR US-4944837-$.DID. OR US-4962776-$.DID. OR US-5185296-$.DID. OR US-5304515-$.DID. OR US-5900354-$.DID. OR US-6071439-$.DID. OR US-6149828-$.DID. OR US-6242165-$.DID. OR US-6306754-$.DID. OR US-6666986-$.DID.	22
☐	L4	L3 and ((semiconductor or wafer or substrate) same supercritical same thermodynamic$4)	3
☐	L3	L2 or l1	31765
☐	L2	(micron technology).as.	31699
☐	L1	farrar-paul$.in.	274

END OF SEARCH HISTORY